



University  
of Glasgow

THE AWARDS  
2020

UNIVERSITY  
OF THE YEAR

# Nanostructured Ultra-Lightweight Lenses for Earth Observation

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WORLD  
CHANGING  
GLASGOW



# Satellite optic – Design considerations & important metrics

## Stability & Reliability

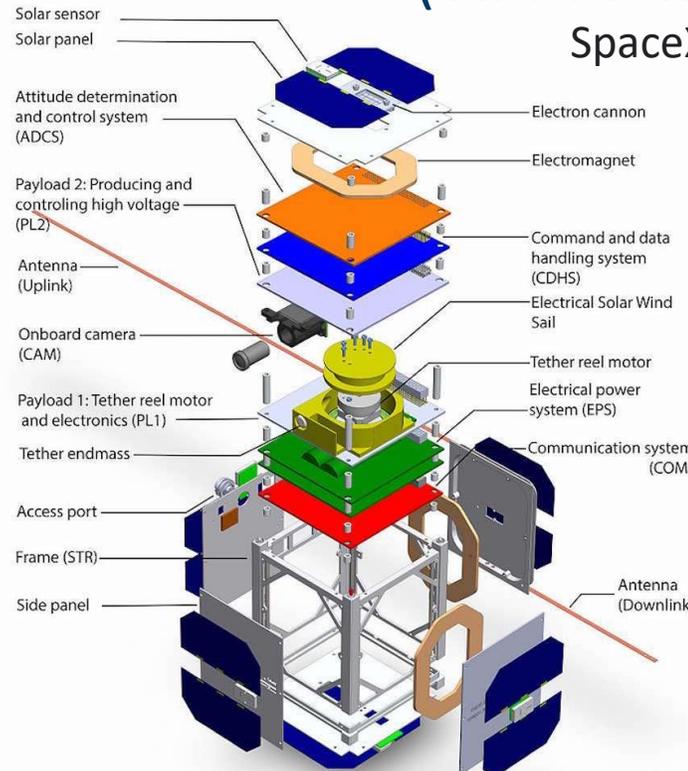
(Vibrations, Temperature, Radiation, etc.)

SpaceX, "Falcon User's guide", (April 2020)

## Weight

→ 5-20 k\$/kg

©Canadian Space Agency



The structure of cubesat ESTCube-1



Slavinskis, Andris, et al. "ESTCube-1 in-orbit experience and lessons learned." *IEEE aerospace and electronic systems magazine* 30.8 (2015): 12-22.

## Performance

e.g. aperture size, efficiency, image acquisition time, image quality

## Compactness

i.e. CubeSat

1U → 11.35cm x 10cm x 10cm

Kuuste, Henri, et al. "Imaging system for nanosatellite proximity operations." *Proceedings of the Estonian Academy of Sciences* 63 (2014).

**HOW HEAVY IS A SATELLITE?**

<b>LARGE SATELLITE</b>	RADARSAT-2	>1000 kg	RHINO
<b>MEDIUM SATELLITE</b>	CASSIOPE	500-1000 kg	BUFFALO
<b>MINI SATELLITE</b>	SCISAT	100-350 kg	LION
<b>MICRO SATELLITE</b>	M3MSat	10-100 kg	WOLF
<b>NANO SATELLITE including CUBESAT</b>	Ex-Alpha 1	1-10 kg	RACCOON
		1 kg per unit	DUCK

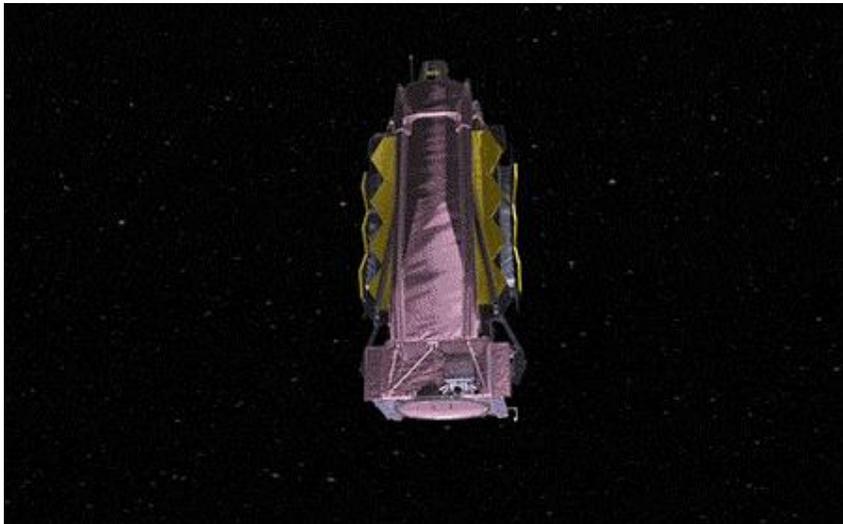
note: These weights are approximations.



# Satellite optic – State of the art technologies

## (Foldable) Au mirrors

- Medium to large apertures
- Good ratio weight ↔ area
- Only compact when folded
- Reflection imaging (larger volume)
- Moving parts (less robust/reliable)



©NASA: James Webb Space Telescope



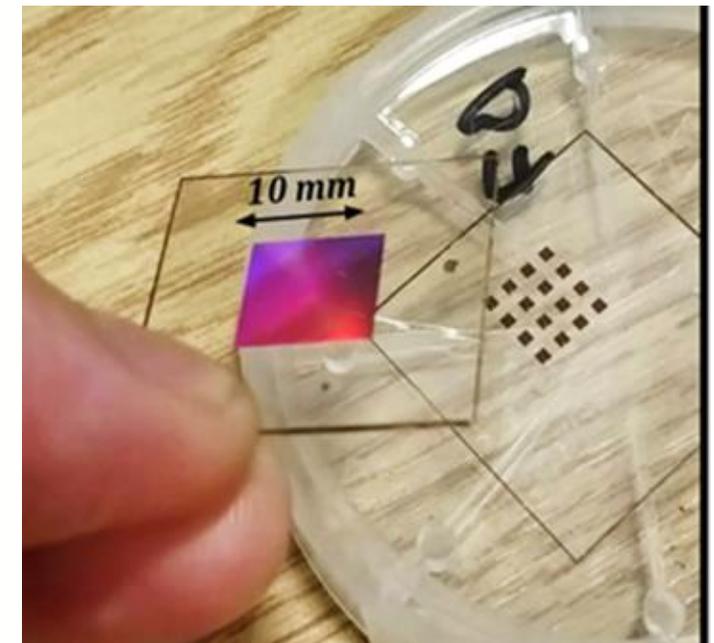
© TH Swiss, Irix  
<https://space.irixlens.com>  
(last accessed 23/06/21)

## Classic (bulk) optic

- Small to medium apertures
- Heavy, i.e. for large NA/aper. [250 g, aperture: 70mm]
- Bulky lens (Transmission)
- Comparably robust
- Very mature technology

## Metasurfaces

- Previously only small apertures
- Ultra Lightweight aperture 70mm→2.2 g (quick math)
- Ultra-compact (planar, Transmission)
- Robustness given by substrate
- Rich, ever advancing capabilities (multiplexing, achromatic, etc.)



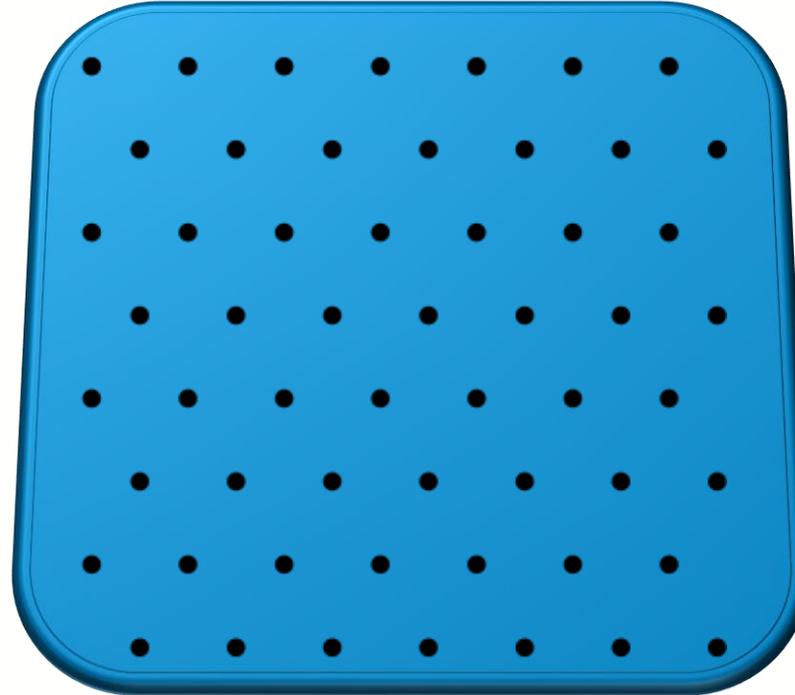


# MetaLens - Design and Physics - I

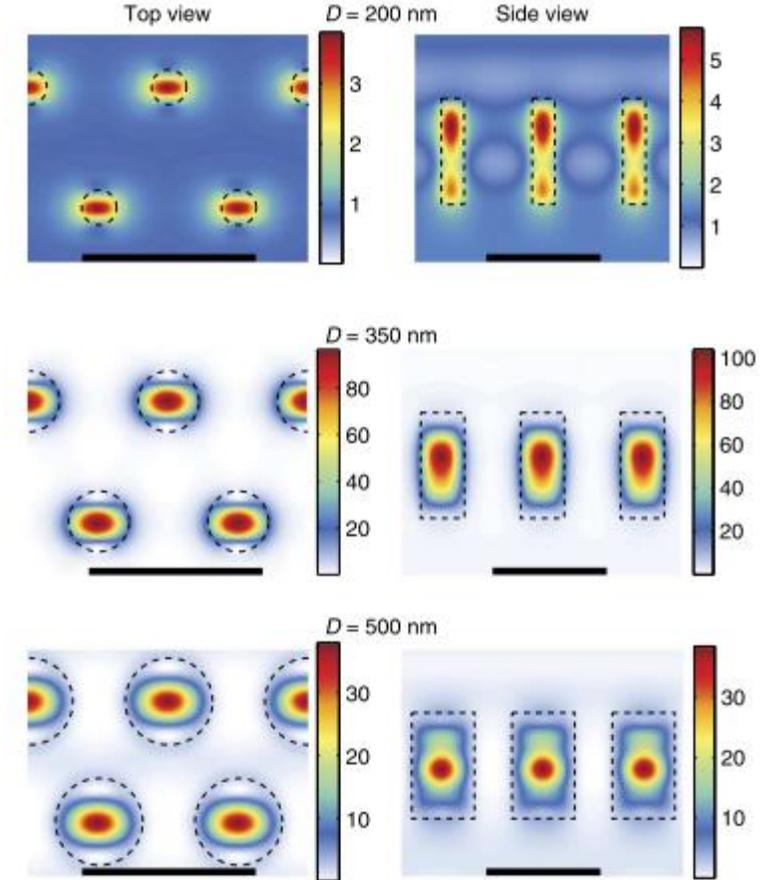
## 1. Choice of materials:

Mech. Support ( $\text{SiO}_2$ ), as thin as possible  
+ active layer (a-Si),  $d \approx 0.5-1 \lambda$   
(MWIR: 3300 nm, SWIR: 1064 nm)

2. Divide continuous surface into discrete, periodic lattice points (sub- $\lambda$  spacing)



## E-field confined in Pillars



Arbabi, Amir, et al. "Subwavelength-thick lenses with high numerical apertures and large efficiency based on high-contrast transmitarrays." *Nature communications* 6.1 (2015): 1-6.



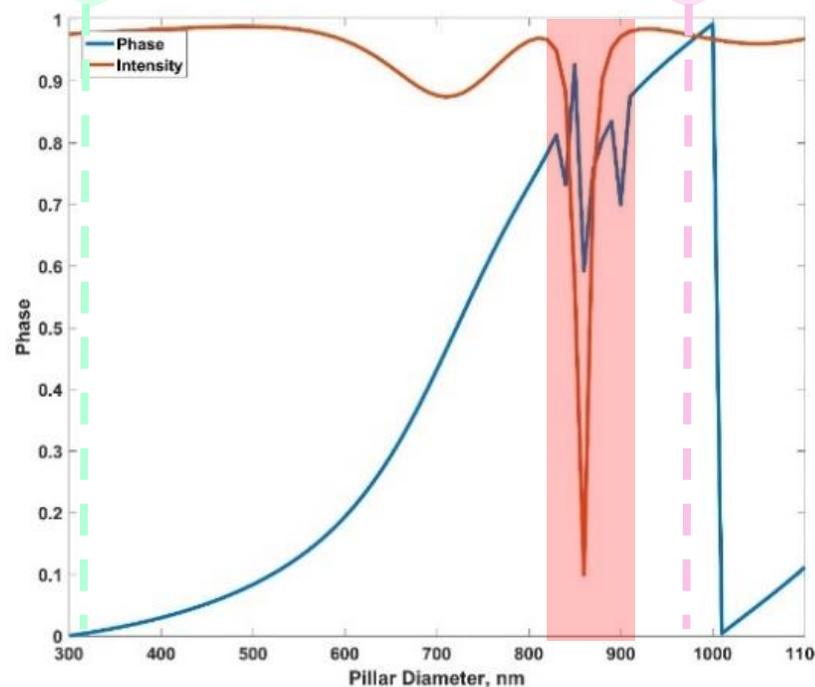
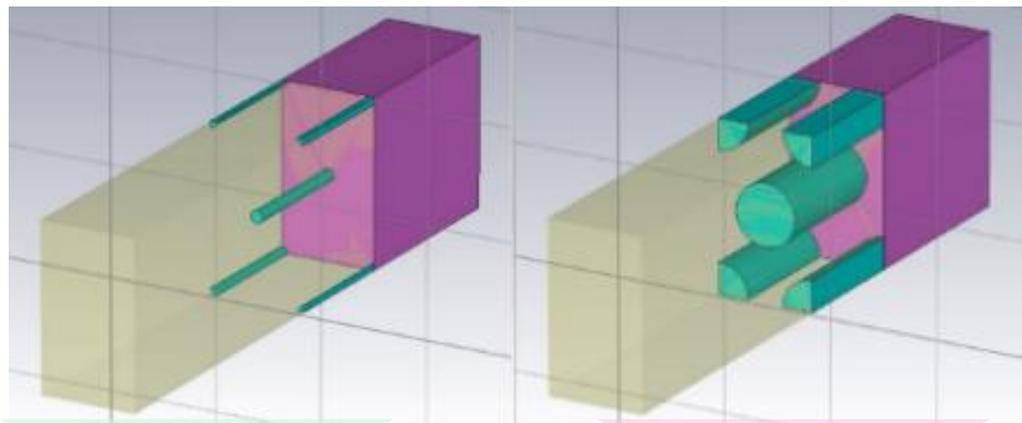
# MetaLens - Design and Physics (MWIR) - II

1. Choice of materials:  
Mech. Support ( $\text{SiO}_2$ ), as thin as possible  
+ active layer (a-Si),  $d \approx 0.5-1 \lambda$   
(MWIR: 3300 nm, SWIR: 1064 nm)

2. Divide continuous surface into discrete, periodic lattice points (sub- $\lambda$  spacing)

3. Simulate Transmitted Phase & Intensity as function of pillar diameter

4. Choose X Pillar dimensions that span phase-shifts  $0-2\pi$  with high transmitted intensity

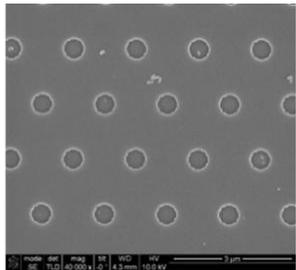
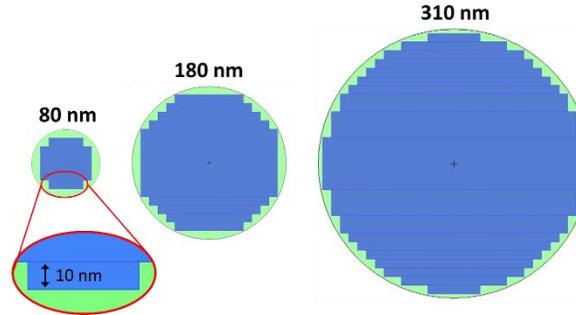


Pillar Diameter	Phase shift [rad]	Transmission [%]
450	0.11	99
600	0.40	96
650	0.58	92
700	0.87	88
750	1.18	90
800	1.41	96
900	1.71	97
1000	1.98	99

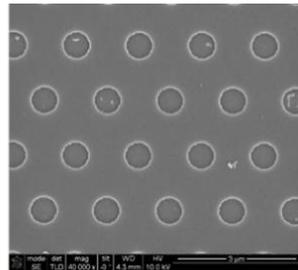
# MetaLens - Design and Fabrication - I

## 5. Develop manufacturing capabilities:

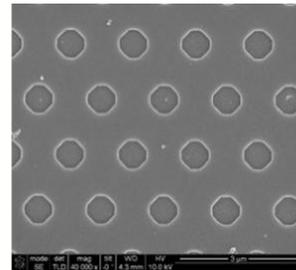
- I. E-beam lithography (PMMA)
- II. NiCr hardmask (lift-off)
- III. Dry-etching ( $C_4F_8:SF_6$  plasma)  
⇒ “Look-up table”



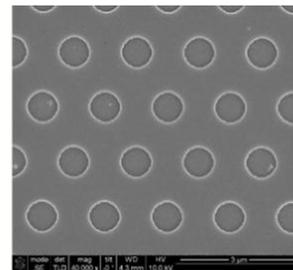
Pillar 1 – 450 nm



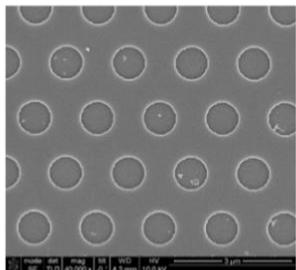
Pillar 2 – 600 nm



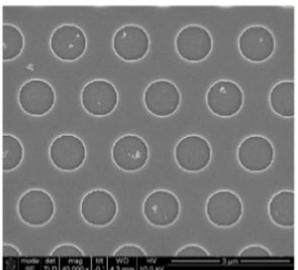
Pillar 3 – 650 nm



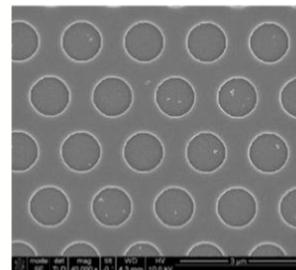
Pillar 4 – 700 nm



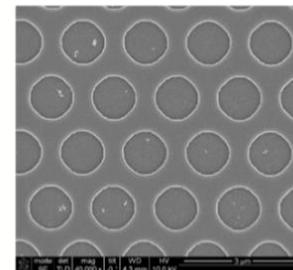
Pillar 5 – 750 nm



Pillar 6 – 800 nm



Pillar 7 – 900 nm



Pillar 8 – 1000 nm

Desired fabricated diameter	Digital diameter (nm)	Exp. Dose ( $\mu C/cm^2$ )
450	450	395
600	600	395
650	600	596
700	650	520
750	700	520
800	750	520
900	800	684
1000	900	596

# MetaLens - Design and Fabrication - II

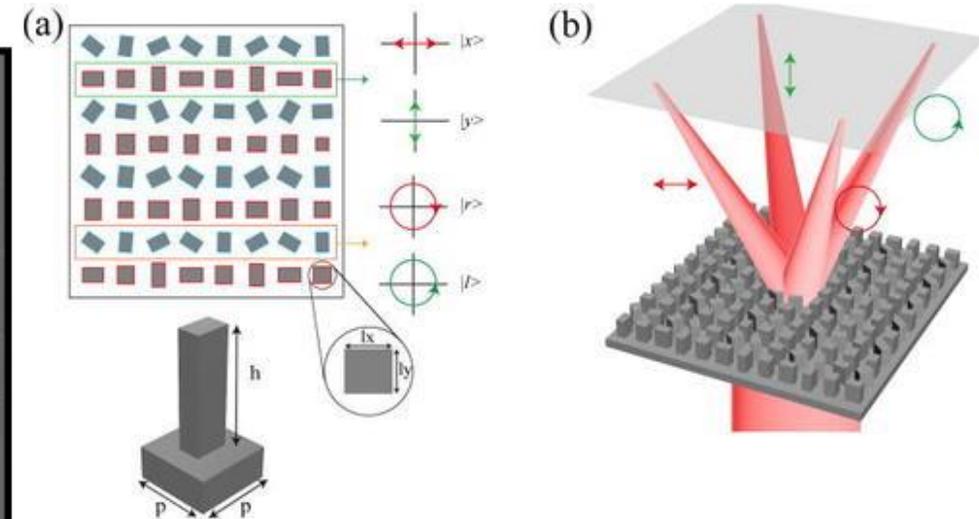
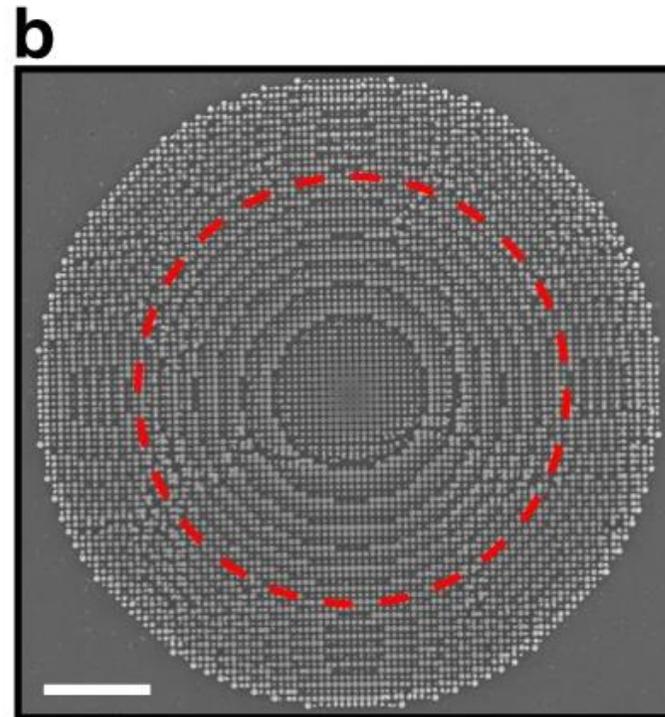
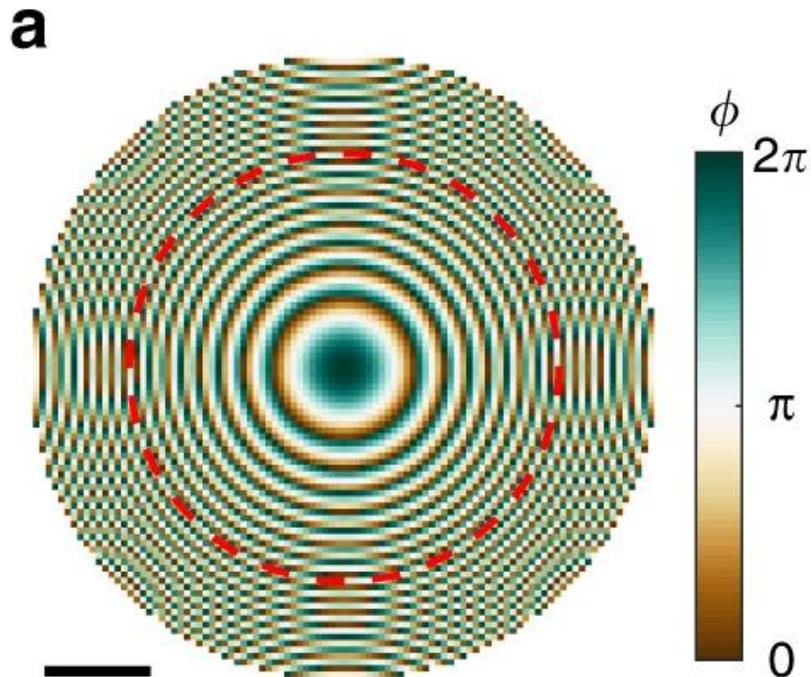
6. Define desired Phase function ( $\lambda, f, D$ ):  
Spherical lens with focal length  $f$

$$\varphi_{theo}(x, y) = \frac{2\pi}{\lambda} \left( \sqrt{f^2 + x^2 + y^2} - f \right) + X$$

At each lattice point:  
Find closest match  
 $\varphi_{theo}(x, y) \leftrightarrow \varphi_{pillar}(x, y)$

Potential for Multiplexing Components:

**X** = e.g. Vortex Phase, diffraction grating, (waveplate, polarimeter), etc.



Yan, Chao, et al. "Midinfrared real-time polarization imaging with all-dielectric metasurfaces." *Applied Physics Letters* 114.16 (2019): 161904.

Huang, Tzu-Yung, et al. "A monolithic immersion metalens for imaging solid-state quantum emitters." *Nature communications* 10.1 (2019): 1-8.

# MetaLens - Design and Fabrication - III

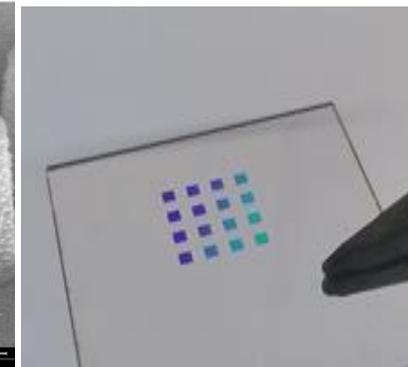
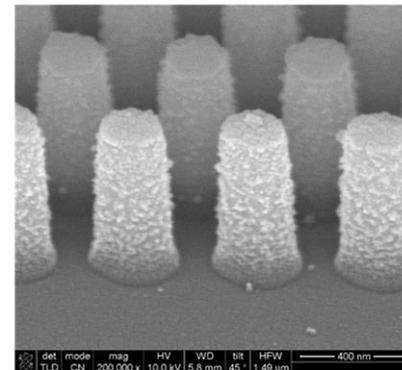
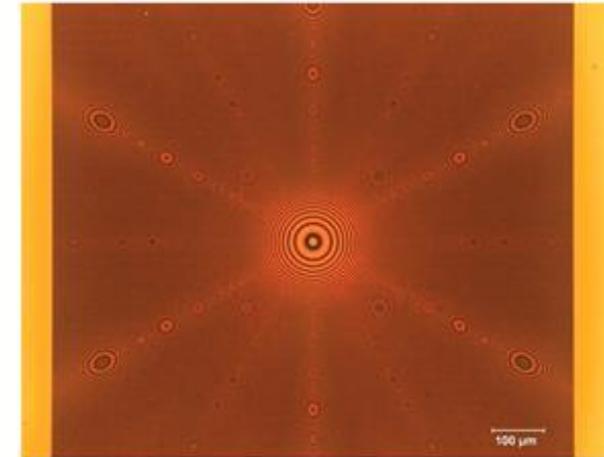
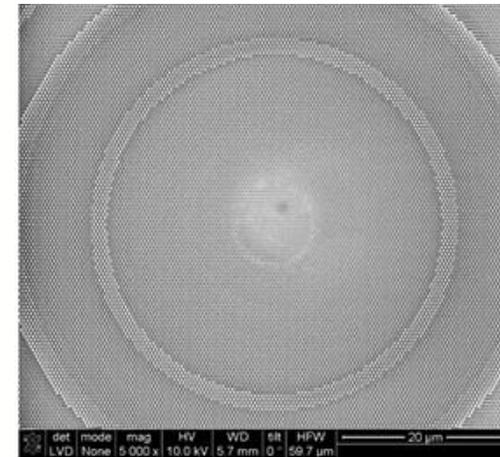
## 7. Generate pattern file for EBL:

- .txt file with lattice point (x,y), .gds Cell and Dose
  - 100x 1mm x 1mm areas (stiching)
- Sequential exposure of pattern pillar dimensions

Number of Elements  $\propto D^2$  !

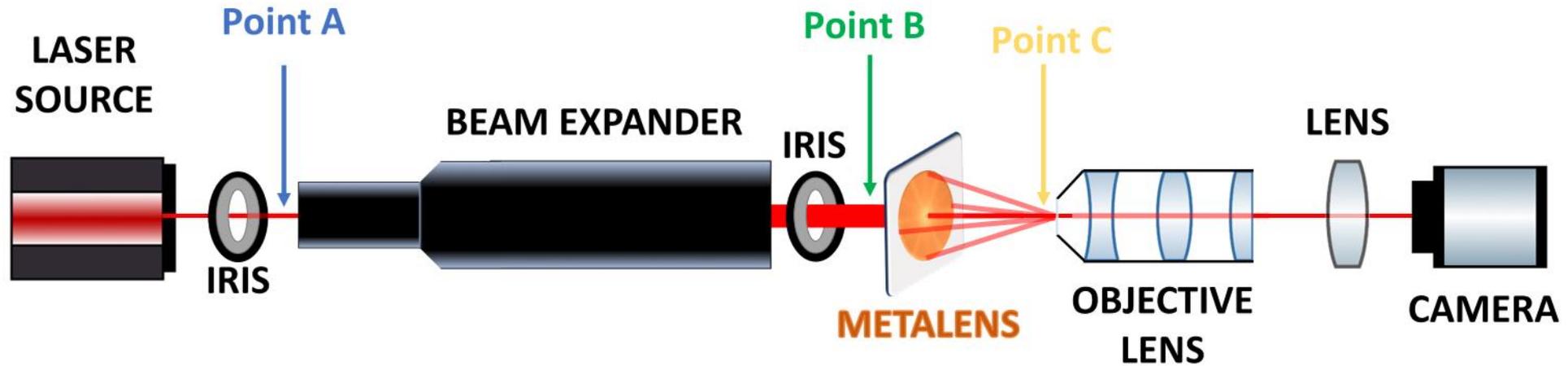
Aperture (A), mm	Focal length (f), mm	Number elements	File Size	Time to calculate
1	5	8'552'478	293 MB	Few hrs
10	50	855'324'780	28.6 GB	2.5-3days
Below after Code Optimisation (MWIR)				
5	5	8'864'385	311 MB	3m 29s
10	10	35'445'295	1.24 GB	13m 58s
20	20	141'733'709	4.98 GB	1hr 2mins

## 8. Manufacture MetaLenses



# Metasurfaces – Optical Testing SWIR Lenses– I

## Efficiency determination

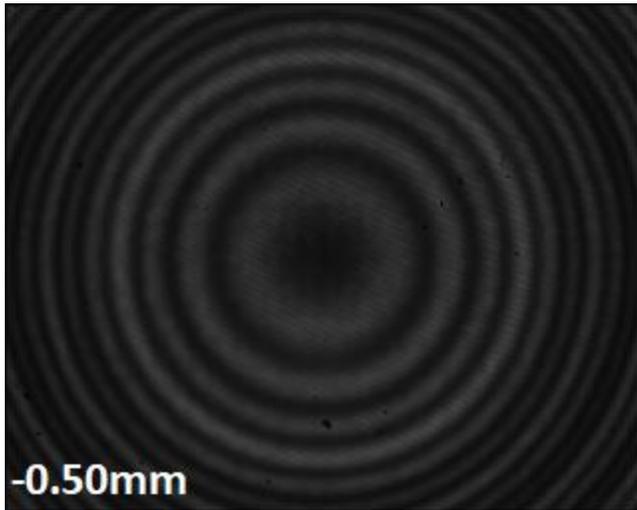


Lens	Averaged Power Values [mW]				Efficiencies [%]	
	Point A	Point B	Point C		Absolute	Relative
			Substrate	Metalens		
<b>F#1 (10 mm)</b>	0.765	0.298	0.287	0.207	<b>69.7</b>	<b>73.4</b>
<b>F#2 (10mm)</b>	0.765	0.306	0.287	0.201	<b>65.8</b>	<b>69.3</b>

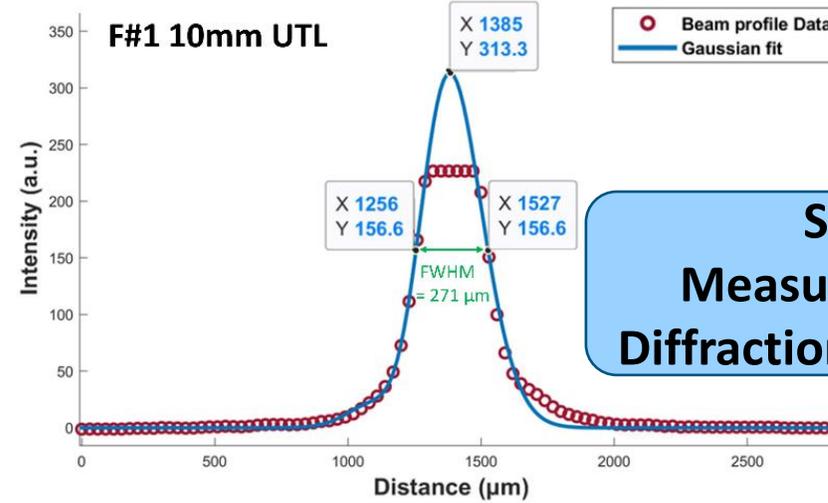
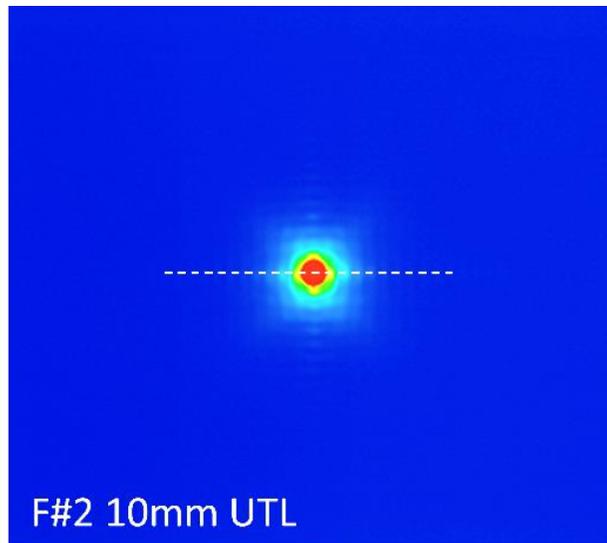
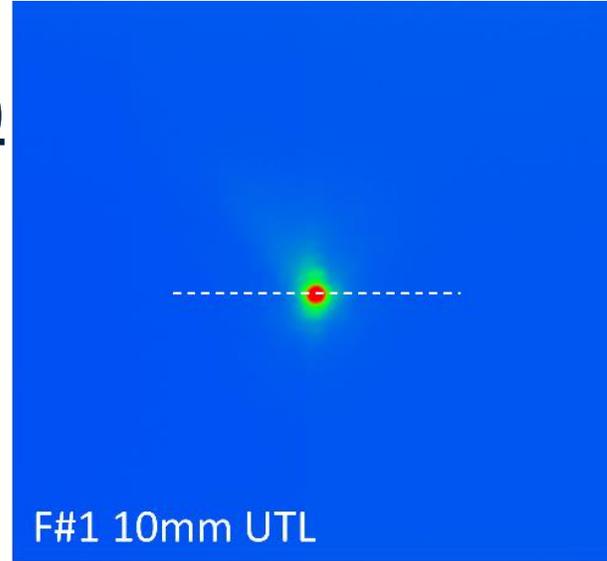


# Metasurfaces – Optical Testing SWIR Lenses – II focal Length and spot size

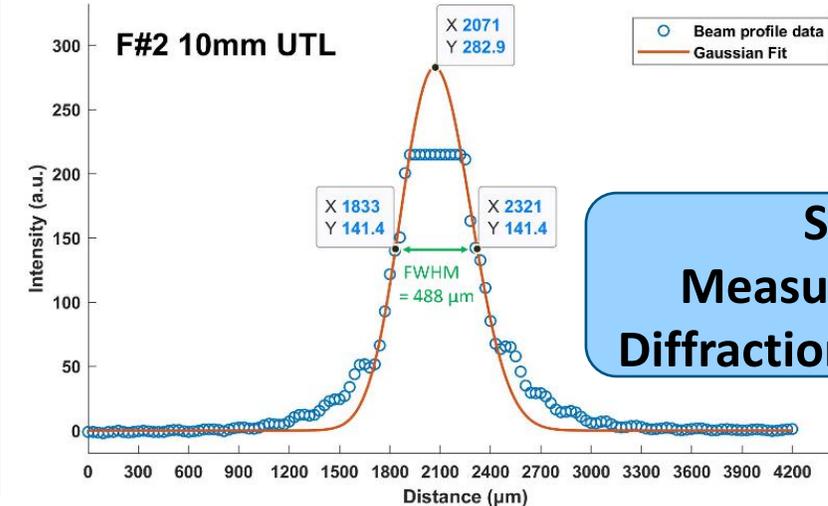
**F = 2 mm (1mm aperture)**



$$SpotSize = \lambda / (2 \cdot NA)$$



**Spotsize**  
Measured: 2.07 μm  
Diffraction limit: 1.19 μm



**Spotsize**  
Measured: 3.73 μm  
Diffraction limit: 2.19 μm

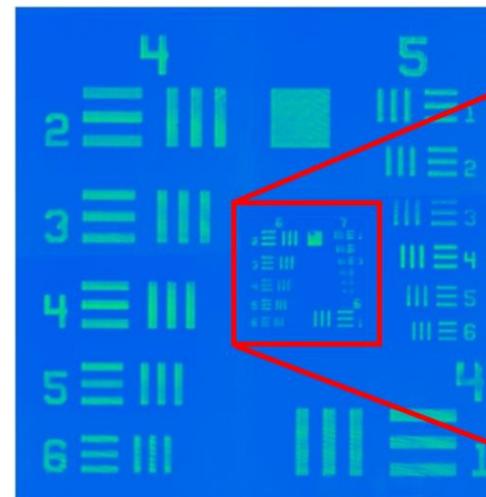
# Metasurfaces – Optical Testing – I

## Imaging with 1951 USAF target

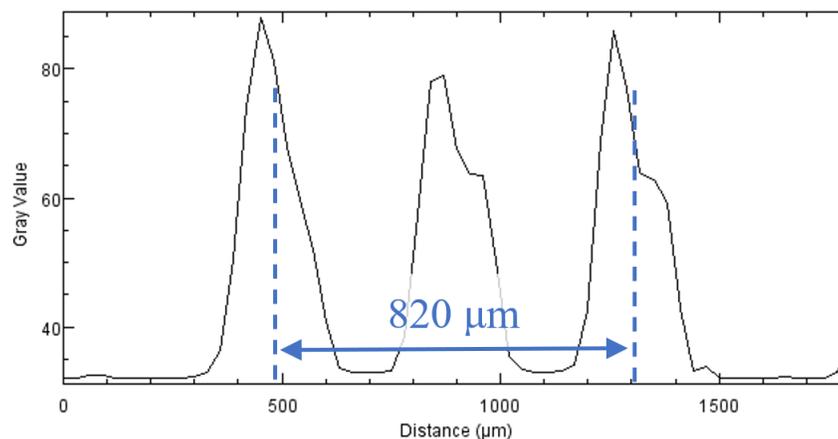
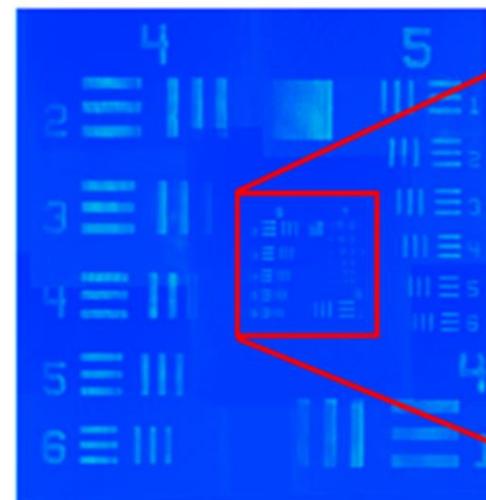
1: Calibrate System magnification ( $\mu\text{m}/\text{pixel}$ )  
with line pair of known dimension

2: Determine max. resolution of MLens  
via smallest resolvable line pair

F#1 (10mm aperture)  
2.76  $\mu\text{m}$  line spacing



F#2 (10mm aperture)  
4.39  $\mu\text{m}$  line spacing



# Achievements and conclusions of the project

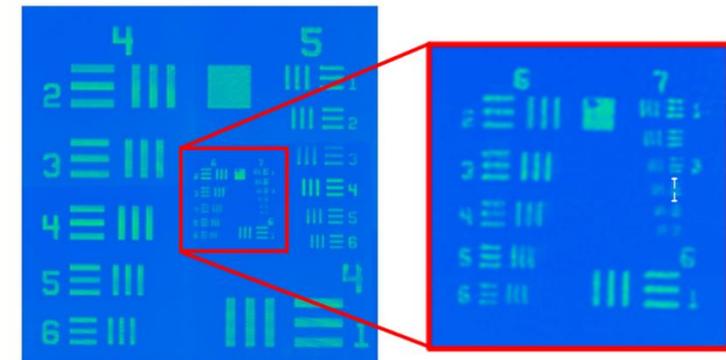
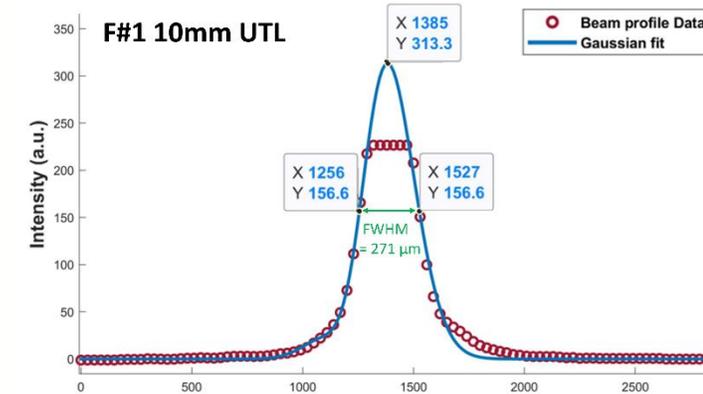
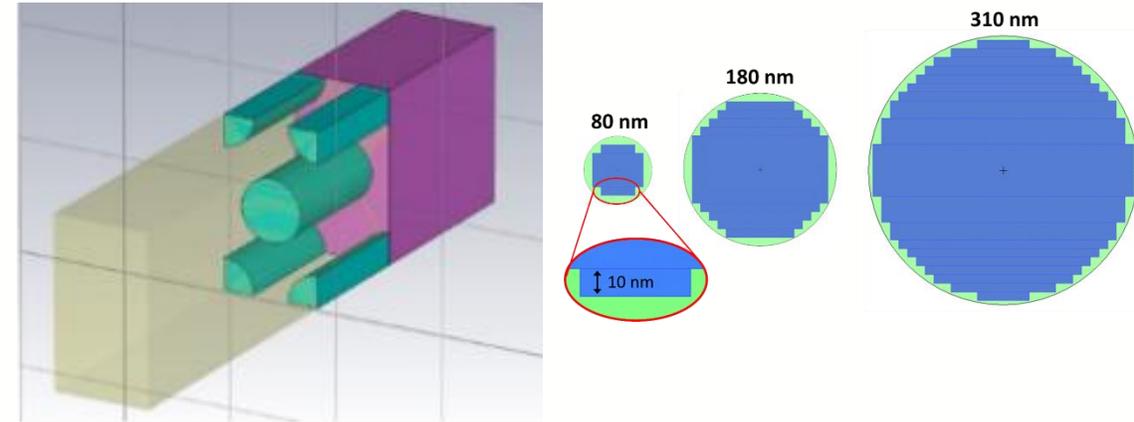
1: Successfully designed & simulated highly efficient MetaLenses for SWIR (1064 nm) & MWIR (3300 nm)

2: Developed and optimised software for fast, large-area pattern generation compatible with commercial EBL technology

3: Developed and optimised manufacturing protocol for large area MetaLenses, incl. Quality Assurance

4: Experimentally confirmed close to diffraction-limited & highly efficient optical performance of manufactured MetaLenses

5: Demonstrated imaging with high spatial resolution (few  $\mu\text{m}$ ) employing manufactured MetaLenses





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**Thank you for your attention!**

**Any Questions?**

**M.Sc. Thomas Nowack – PhD candidate in MSCA “TeraApps”  
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